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(12) **United States Design Patent** (10) **Patent No.:** **US D890,572 S**
Saiki et al. (45) **Date of Patent:** **** Jul. 21, 2020**

(54) **GAS SUPPLY NOZZLE FOR SUBSTRATE PROCESSING APPARATUS**

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(**) Term: **15 Years**

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(21) Appl. No.: **29/672,652**

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(22) Filed: **Dec. 7, 2018**

* cited by examiner

(30) **Foreign Application Priority Data**

Jul. 19, 2018 (JP) 2018-015810

(51) **LOC (12) Cl.** **07-99**

(52) **U.S. Cl.**
USPC **D7/407**; D23/213

(58) **Field of Classification Search**
USPC D7/407, 332, 334-337, 402-405, 391,
D7/392.1; D24/108; D23/213, 259, 266,
D23/262, 263, 386, 387, 421
CPC F23D 14/045; F23D 14/16; F23D 14/48;
F23D 14/50; F23D 2203/10; F23D
2203/1012; F32D 14/10; B24B 9/007;
B08B 9/00; B08B 9/021; B08B 9/032;
B08B 9/027; B08B 9/02
See application file for complete search history.

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(57) **CLAIM**

We claim the ornamental design for a gas supply nozzle for substrate processing apparatus, as shown and described.

DESCRIPTION

FIG. 1 is a front, top and right side perspective view of a gas supply nozzle for substrate processing apparatus showing our new design;

FIG. 2 is a front elevational view thereof;

FIG. 3 is a rear elevational view thereof;

FIG. 4 is a left side elevational view thereof;

FIG. 5 is a right side elevational view thereof;

FIG. 6 is a top plan view thereof;

FIG. 7 is a bottom plan view thereof; and,

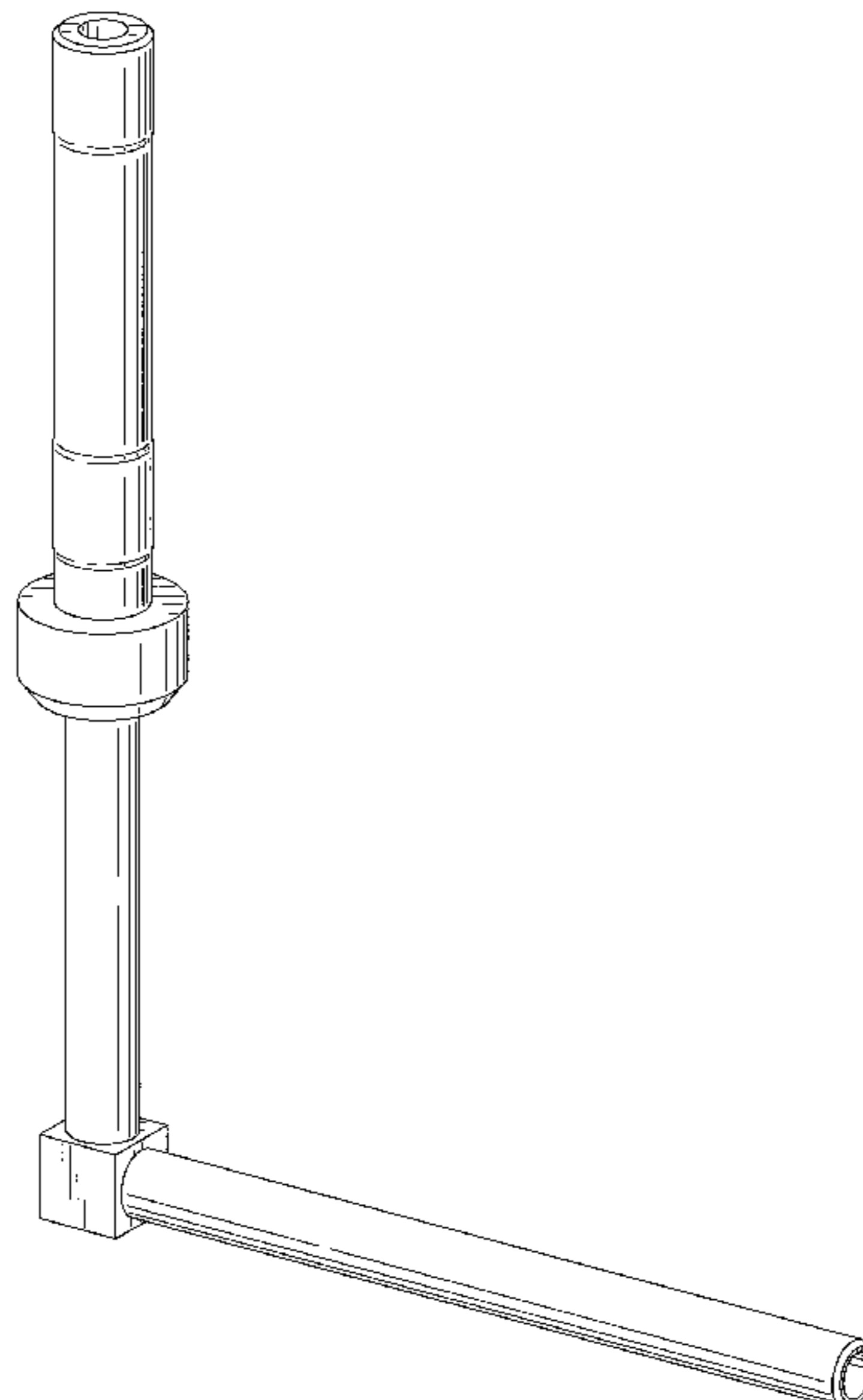
FIG. 8 is a cross-sectional view take along line 8-8 in FIG. 5.

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1 Claim, 6 Drawing Sheets



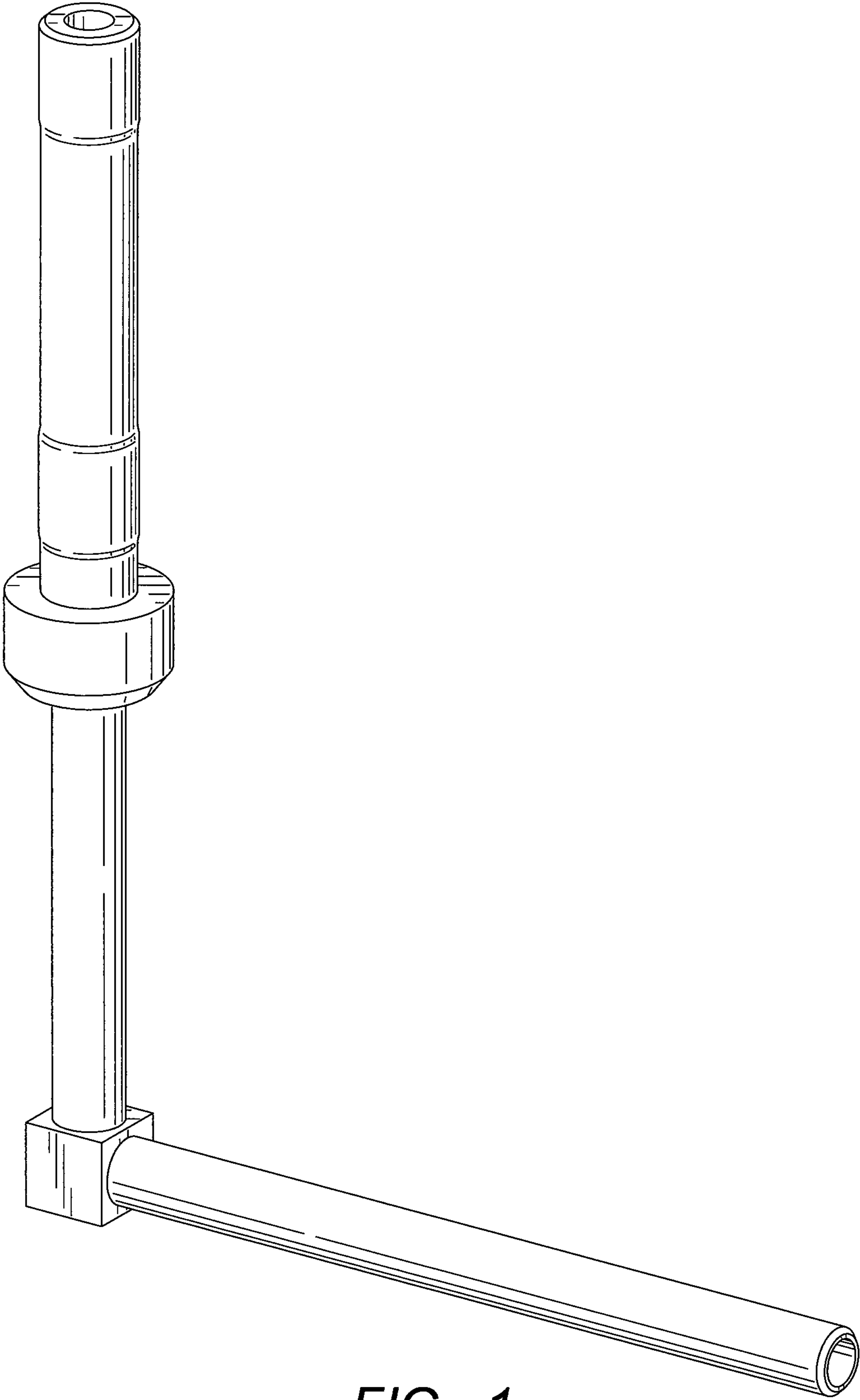


FIG. 1

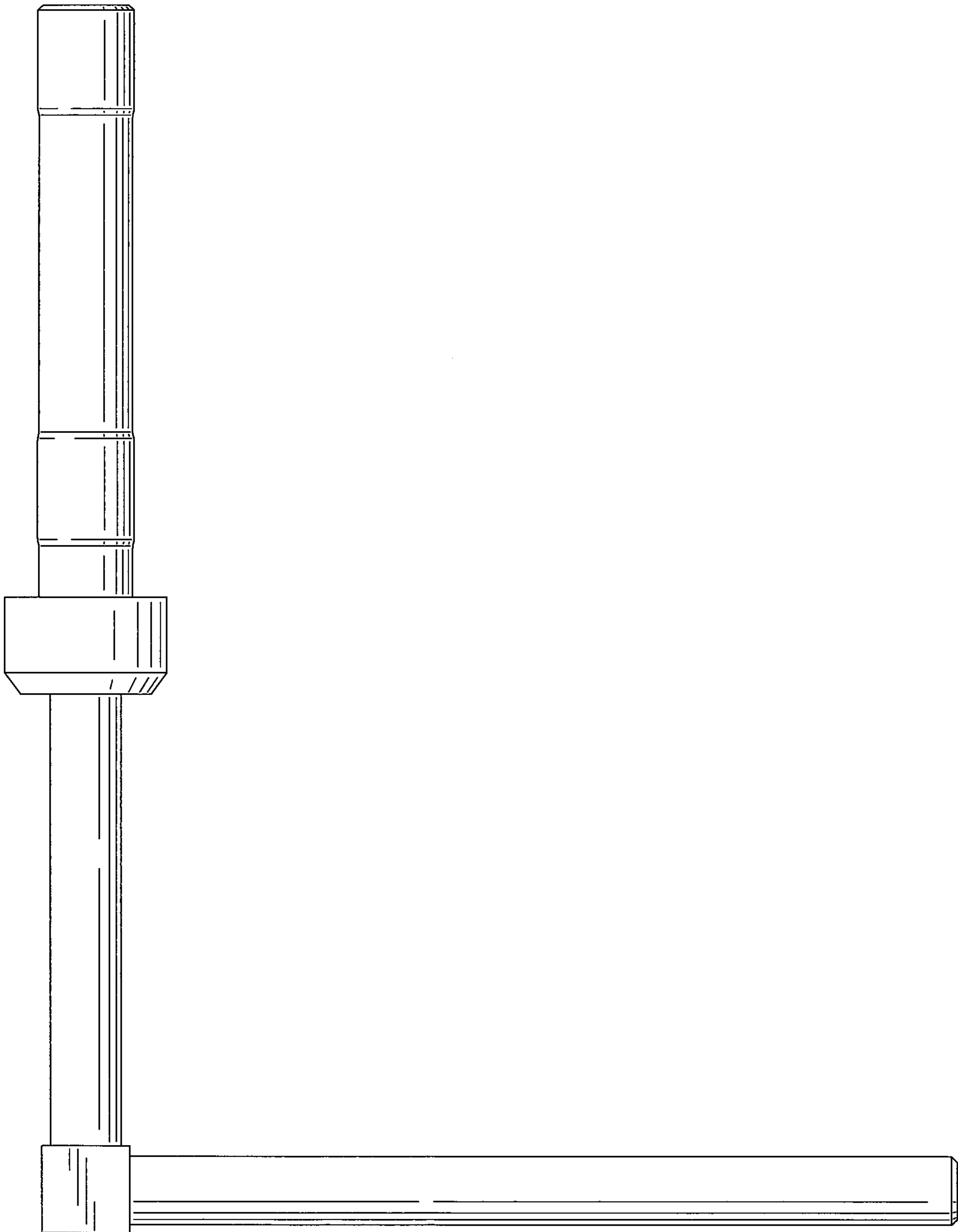


FIG. 2

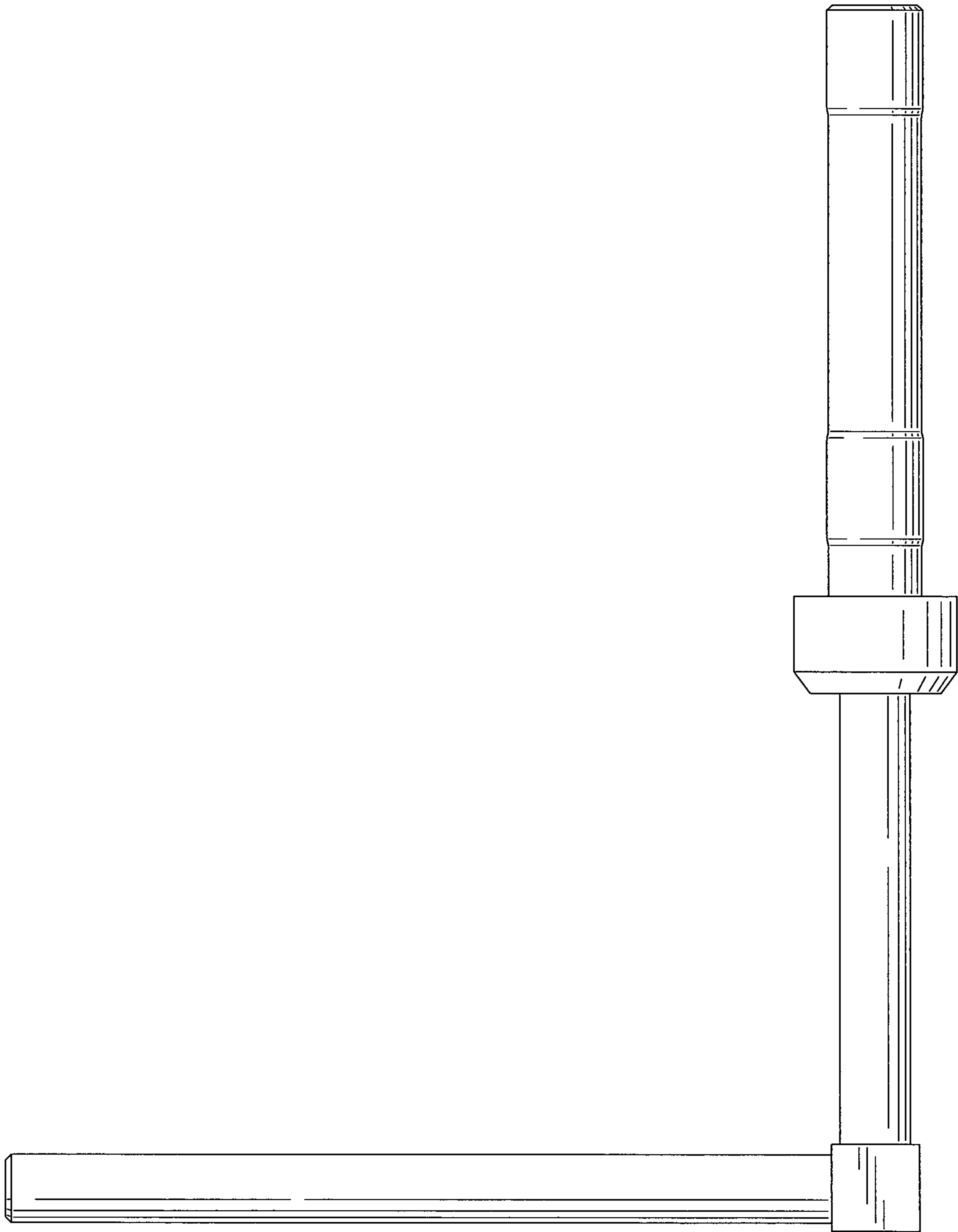


FIG. 3

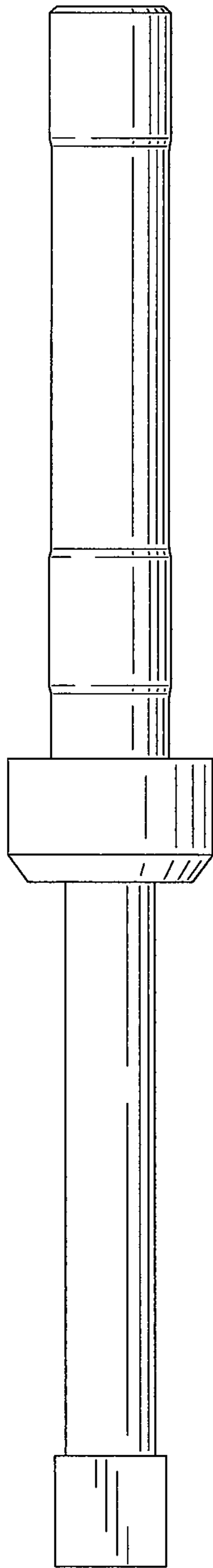


FIG. 4

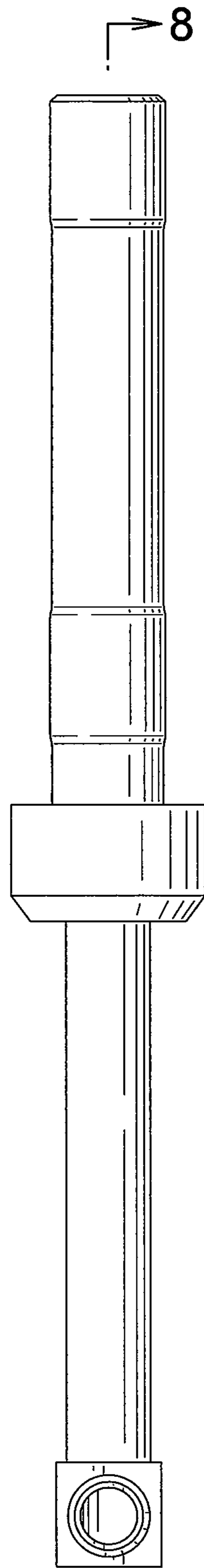


FIG. 5

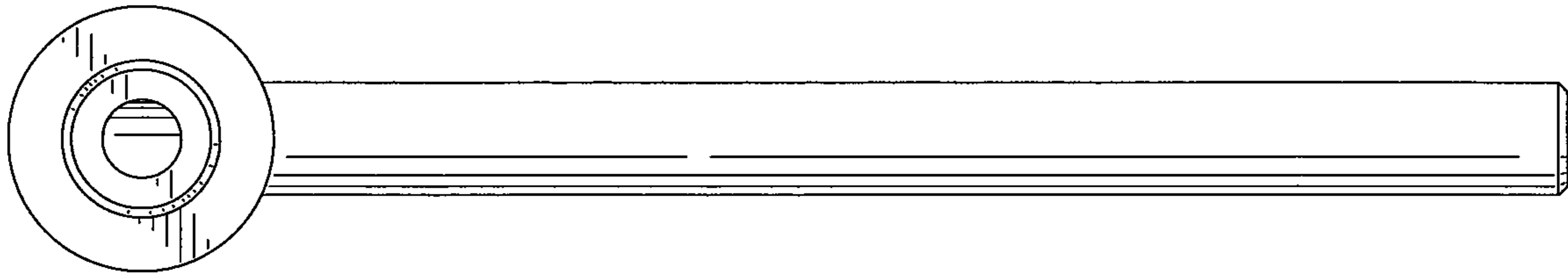


FIG. 6

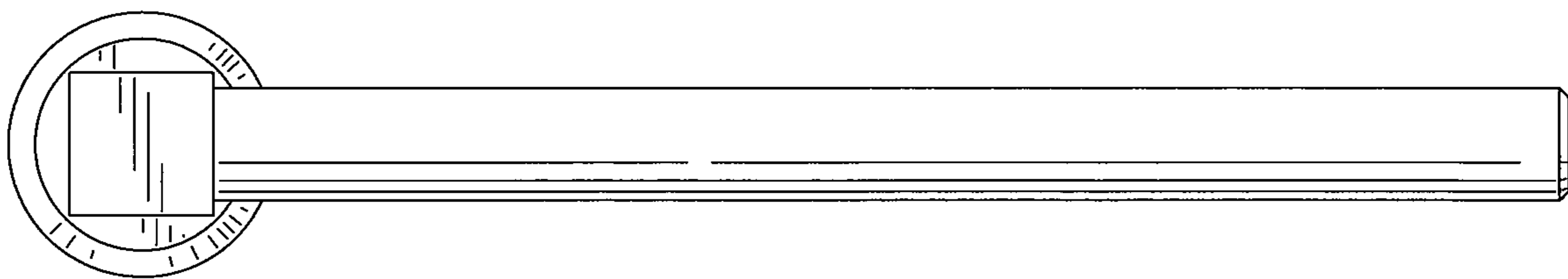


FIG. 7

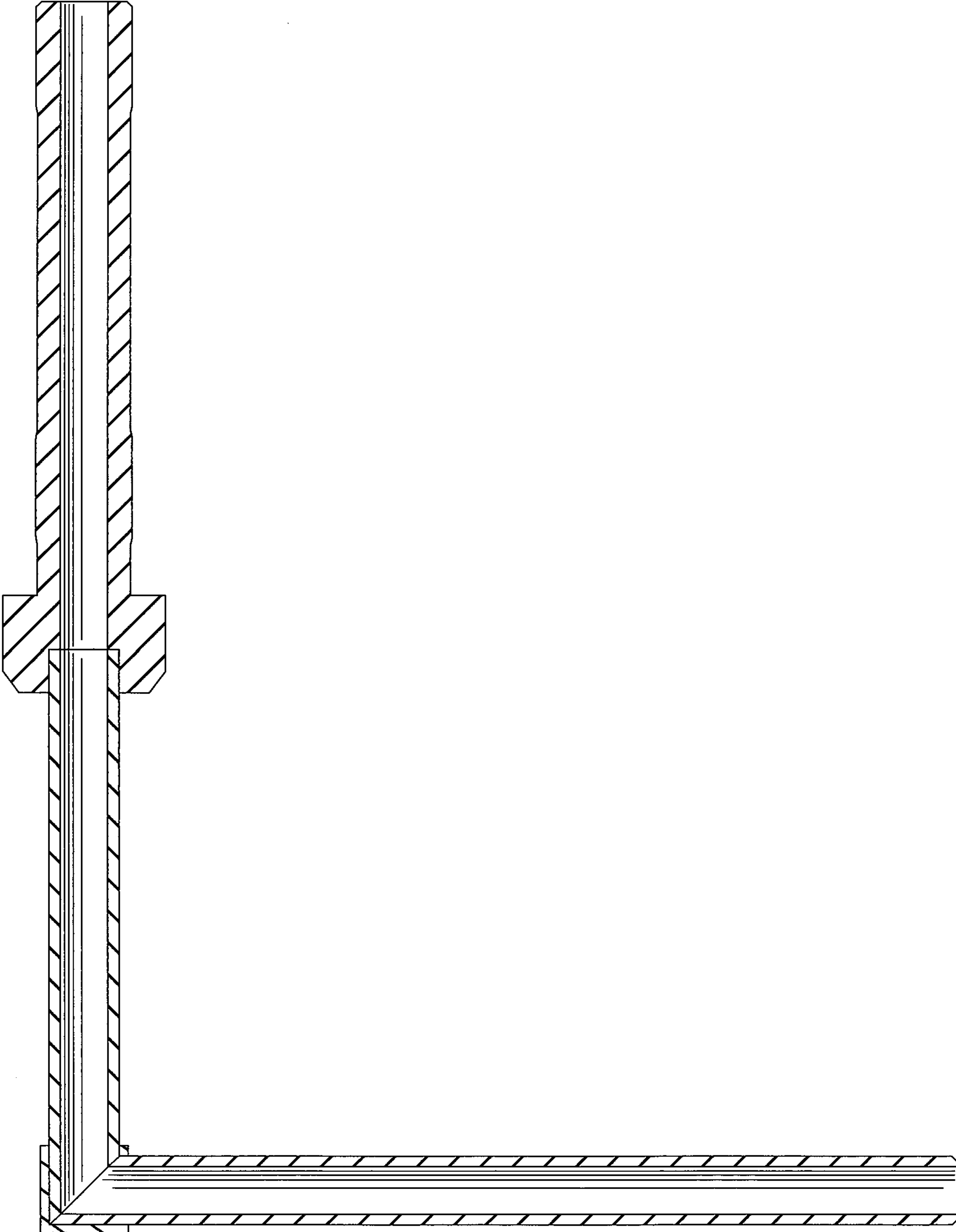


FIG. 8